Application No
INCORPORTION DISCLOSURE

STATEMENT BY APPLICANT

(Multiple sheets used when necessary)

Application No
Filing Date

First Named In
Art Unit

Examiner

SHEET 1 OF 1

Application No.	10/822,424
Filing Date	April 12, 2004
First Named Inventor	Bulent M. Basol et al.
Art Unit	1742 1709
Examiner	Unknown Zulmariam Méndez
Attorney Docket No.	NVLUS.029CPI

	U.S. PATENT DOCUMENTS						
Examiner Initials	Cite No.	Document Number Number - Kind Code (if known) Example: 1,234,567 B1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear		
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(-)	NON PATENT LITERATURE DOCUMENTS				
/ZM/ Examine Initials	er Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	. T <sup>1</sup>		

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Examiner Signature	/Zulmariam Mendez/	Date Considered	05/07/2007

<sup>\*</sup>Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

•		Application No.	10/822,424
6	I P ENFORMATION DISCLOSURE	Filing Date	April 12, 2004
	STATEMENT BY APPLICANT	First Named Inventor	Bulent Basol, et al.
<b>(Δ</b> R	OT 2006	Art Unit	H742 1709
W111	Multiple sheets used when necessary)	Examiner	Unknown /Zulmariam Mendez/
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U.S. PATENT DOCUMENTS						
Examiner Initials Cite No. Cite No. Cite No. Example: 1,234,567 B1  Document Number Publication Date MM-DD-YYYY  Name of Patentee or Applicant Pages, Columns, Lines When Pages, Column						
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Examiner Signature /Zulmariam Mendez/ Date Considered 05/07/2007

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INFORMATION DISCLOSURE INFORMATION DISCLOSURE

(Multiple sheets used when necessary) SHEET 1 OF 4

	PTO/SB/08 Equivalent
Application No.	10/822,424
Filing Date	April 12, 2004
First Named Inventor	Basol et al.
Art Unit	<del>1742</del> 1709
Examiner	Unknown /Zulmariam Mendez/
Attorney Docket No.	ASMNUT.029CP1

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	Application No.	10/822,424
INFORMATION DISCLOSURE	Filing Date	April 12, 2004
STATEMENT BY APPLICANT	First Named Inventor	Basol et al.
STATEMENT BY AFFEIGANT	Art Unit	1742 1709
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SHEET 2 OF 4	Attorney Docket No.	ASMNUT.029CP1

	U.S. PATENT DOCUMENTS						
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## Application No. 10/822,424 INFORMATION DISCLOSURE Filing Date April 12, 2004 First Named Inventor Basol et al. STATEMENT BY APPLICANT 1709 1742 **Art Unit** Unknown /Zulmariam Mendez/ (Multiple sheets used when necessary) Examiner SHEET 3 OF 4 ASMNUT.029CP1 Attorney Docket No.

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Examiner Initials	Cite No.	Document Number Number - Kind Code (if known) Example: 1,234,567 B1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear
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PTO/SB/08 Equivalent

## 10/822,424 Application No. INFORMATION DISCLOSURE April 12, 2004 **Filing Date** First Named Inventor Basol et al. STATEMENT BY APPLICANT 1709 1742 Art Unit <del>Unknown</del> (Multiple sheets used when necessary) Examiner /Zulmariam Mendez/ SHEET 4 OF 4 ASMNUT.029CP1 Attorney Docket No.

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